Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/866,337	CHEN, DARREN	
Examiner	Art Unit	
Arnel C. Lavarias	2872	

Arnel C. Lavarias

	SEAR	CHED	
Class	Subclass	Date	Examiner
359	580,583,5 84,577,61 8,628,634	2/23/2005	ACL
359	636,639	2/23/2005	ACL
369	44.37	2/23/2005	ACL
250	226	2/23/2005	ACL
360	122	2/23/2005	ACL
369	112.19	2/23/2005	ACL
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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DATE 2/23/2005	EXMR
2/23/2005	ACL
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